

In re the Application of: FUJITA, Kenichi

Group Art Unit: 1773

Serial No.: 10/660,745

Examiner: Monique R. Jackson

Filed: September 12, 2003

P.T.O. Confirmation No.: 5996

HEAT RADIATION SHIELDING COMPONENT DISPERSION, PROCESS FOR For. ITS PREPARATION AND HEAT RADIATION SHIELDING FILM FORMING COATING LIQUID, HEAT RADIATION SHIELDING FILM AND HEAT RADIATION RESIN FORM WHICH ARE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: October 25, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated May 30, 2006 for two months, from August 30, 2006 to October 30, 2006.

Attached please find a check in the amount of \$450.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,

HANSON & BROOKS, LLP

Agent for Applicant

Reg. No. 42,573

PATENT TRADEMARK OFFICE

10/26/2006 CNGUYEN 00000058 10660745

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450.00 OP

DAG/bh

Atty. Docket No. 031043

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